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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

OHMORI, K.

Atty. Ref.: 829-613

Serial No. 10/622,566

Group:

Filed: July 21, 2003

Examiner:

For: METHOD FOR CREATING MASK PATTERN FOR  
CIRCUIT FABRICATION AND METHOD FOR  
VERIFYING MASK PATTERN FOR CIRCUIT  
FABRICATION

\* \* \* \* \*

Commissioner for Patents  
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Alexandria, VA 22313-1450

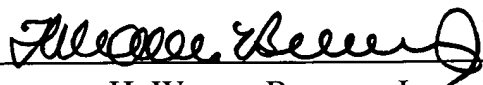
Sir:

**STATUS INQUIRY**

An application was filed on July 21, 2003. However, since then applicant has not received any Official Action from the Patent Office regarding the application. Inquiry is made as to when an Action will be forthcoming. **Please direct any response to this inquiry to Linda Hull at telephone number (703) 816-4127.**

Respectfully submitted,  
**NIXON & VANDERHYE P.C.**

January 21, 2005

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